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10587592 - GAI: 1792

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	Filing Date		2006-07-28	
	First Named Inventor	Tomomi MEGURO et al.		
	Art Unit	1792		
	Examiner Name	Talbot, Brian		
	Attorney Docket Number	81844.0051		

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	2	Li et al. "Growth of High Quality ZnO Thin Films at Low Temperature on Si(100) Substrates by Plasma Enhanced Chemical Vapor Deposition" Journal of Vacuum Science and Technology: Part A AVS/AIP, Melville, Vol. 20, No. 1, 2002 No month available	<input type="checkbox"/>
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